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(54) **ORGANIC LIGHT EMITTING DISPLAY DEVICE**

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(71) Applicant: **Samsung Display Co., Ltd.**, Yongin-city (KR)

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(72) Inventor: **Won-Kyu KWAK**, Yongin-City (KR)

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USPC **257/40; 438/26**

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(57) **ABSTRACT**

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An organic light emitting display device includes a first substrate, a pixel array, metal patterns, a second substrate, and a frit. The pixel array is disposed on a first substrate. The metal patterns are arranged on the first substrate to surround the pixel array. The second substrate is disposed on the first substrate. The frit is disposed between the first substrate and the second substrate, the frit covering the metal patterns.

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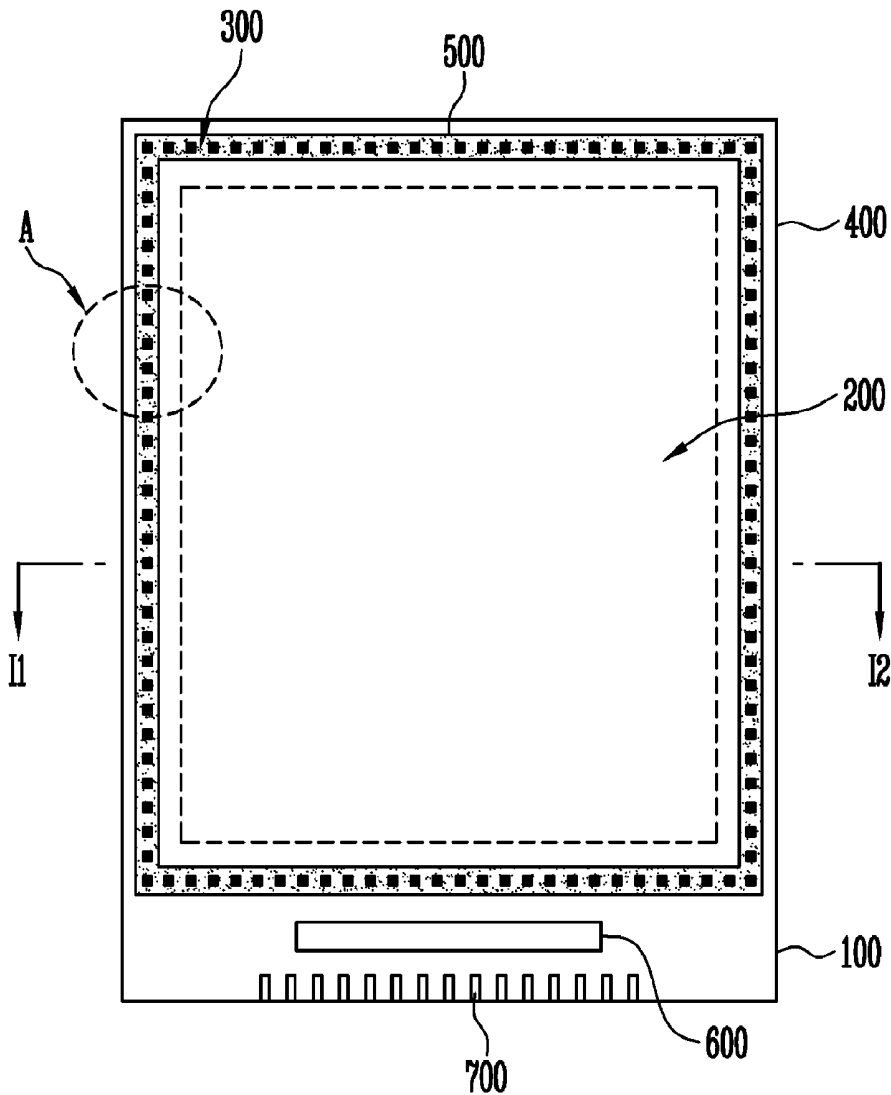


FIG. 1

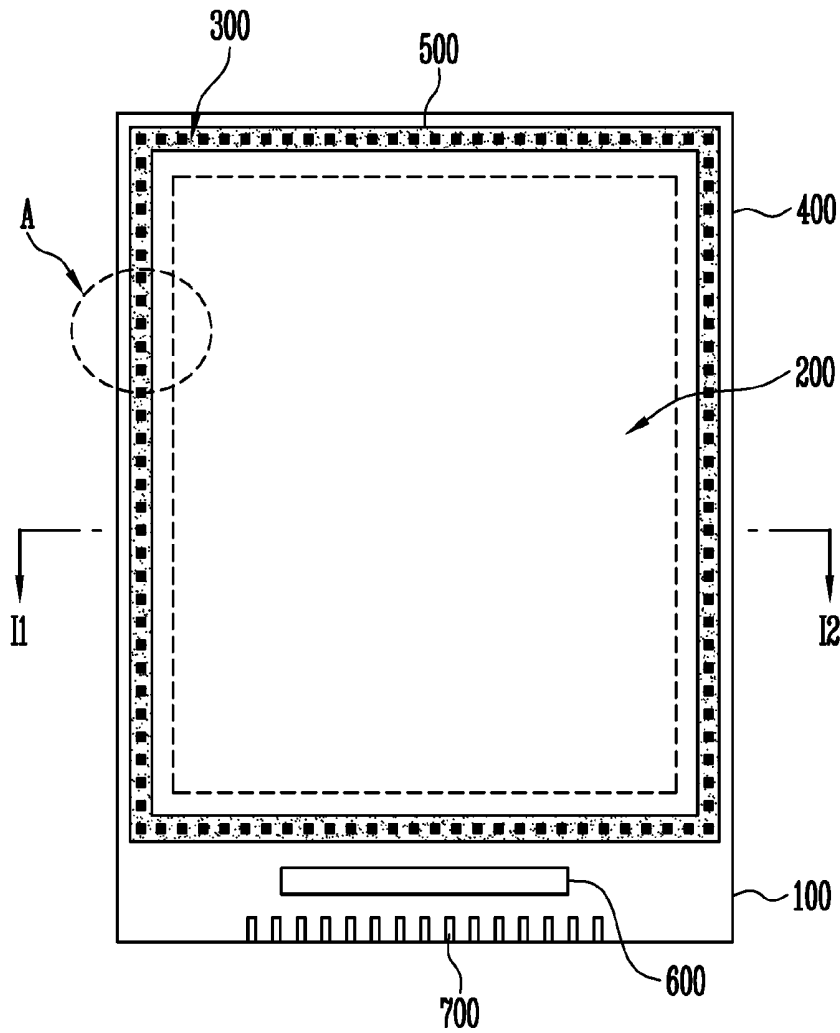


FIG. 2

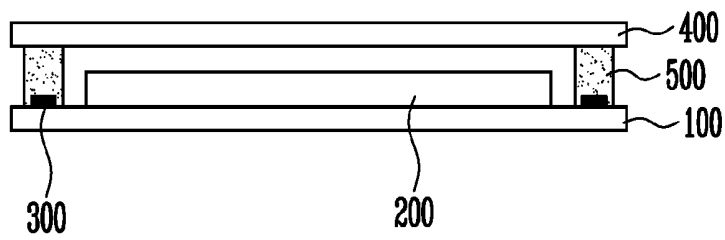


FIG. 3

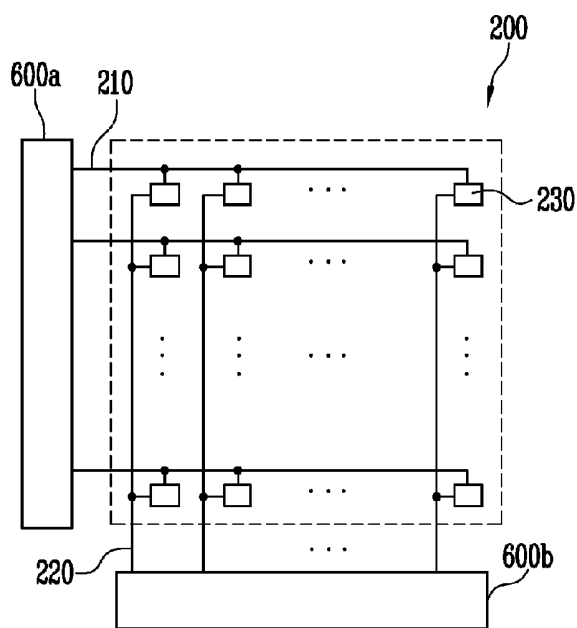


FIG. 4

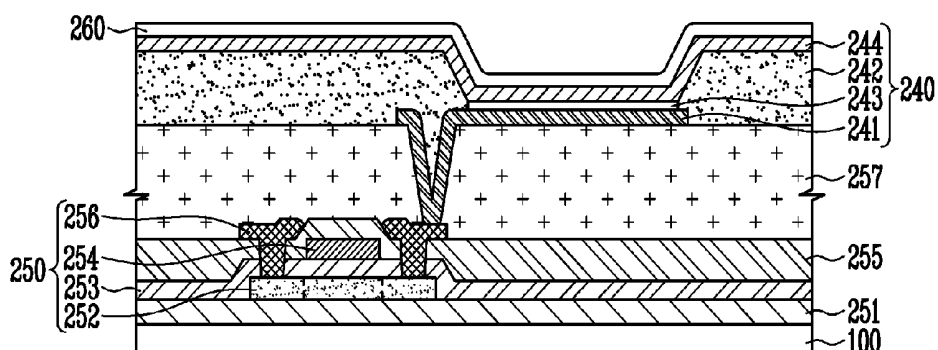


FIG. 5A

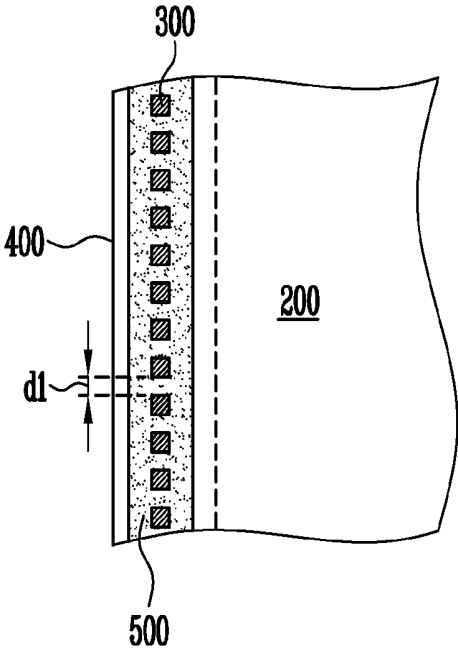


FIG. 5B

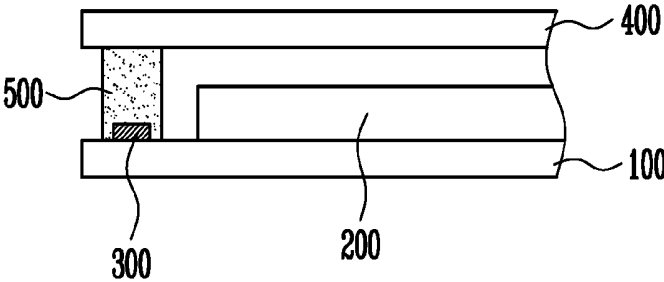


FIG. 6A

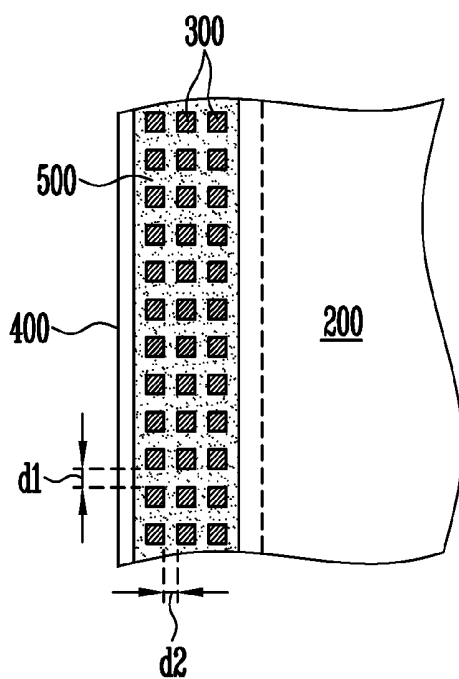


FIG. 6B

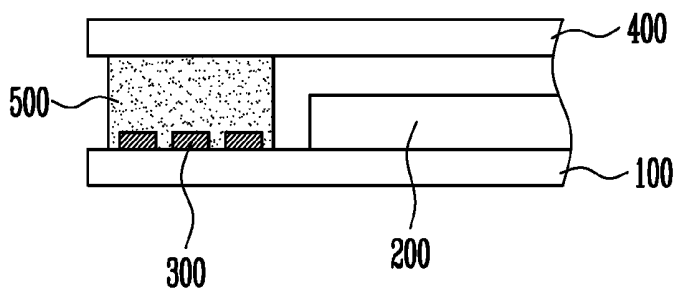


FIG. 7A

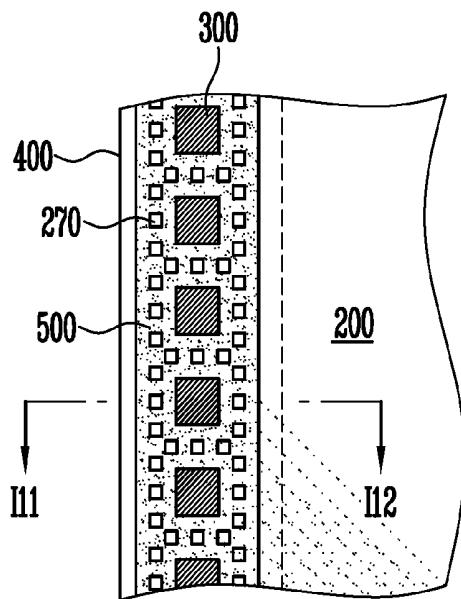


FIG. 7B

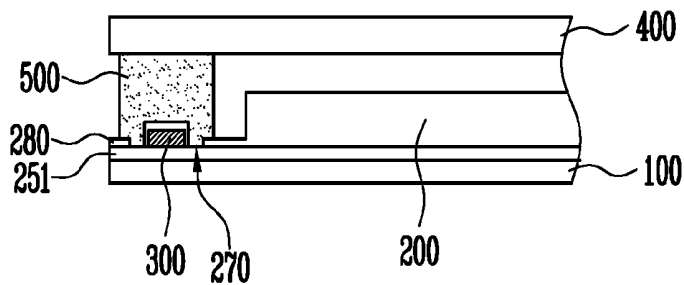


FIG. 8A

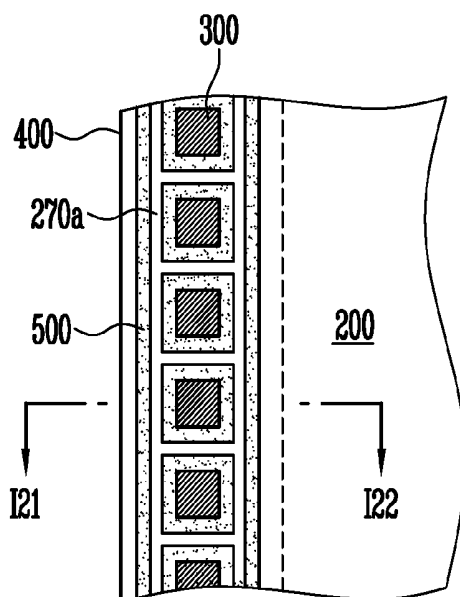
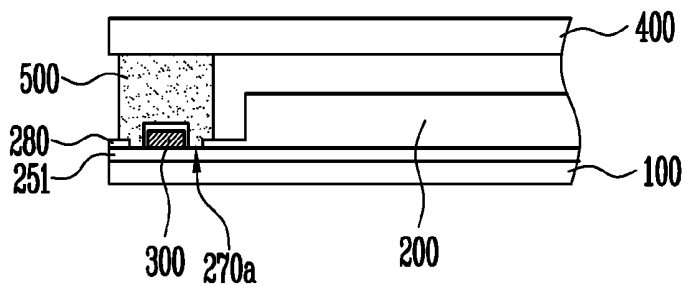


FIG. 8B



ORGANIC LIGHT EMITTING DISPLAY DEVICE

RELATED APPLICATIONS

[0001] This application claims priority to and the benefit of Korean Patent Application No. 10-2013-0085854, filed on Jul. 22, 2013, in the Korean Intellectual Property Office, which is hereby incorporated by reference for all purposes as if fully set forth herein.

BACKGROUND

[0002] 1. Field

[0003] Exemplary embodiments of the present invention relate to an organic light emitting display device. More specifically, the exemplary embodiments of present invention relate to an organic light emitting display device in which its substrates are sealed with a frit.

[0004] 2. Discussion of the Background

[0005] Organic light emitting display devices are next-generation display devices having a self-luminescent property. In general, organic light emitting display devices have excellent characteristics in terms of viewing angle, contrast, response speed, power consumption, etc., compared to liquid crystal display devices. Due to its self-luminescent property, organic light emitting display devices do not require a backlight; hence the organic light emitting display devices can be fabricated relatively light and thin.

[0006] In generally, an organic light emitting display device includes a substrate on which a pixel array is formed, and a container or encapsulating substrate disposed opposite to the substrate, which is bonded to the substrate by a sealant such as epoxy to encapsulate the pixel array.

[0007] The pixel array includes scan lines, data lines, and a plurality of pixels connected in a matrix form between the scan lines and the data lines. Each pixel may include an organic light emitting diode. The organic light emitting diode includes an anode, a cathode, and an organic thin film layer formed between the anode and cathode. The organic thin film layer may include an organic material, such as a hole transport layer, an organic emissive layer, and an electron transport layer.

SUMMARY

[0008] Exemplary embodiments of the present invention provide an organic light emitting display device designed to improve a bonding force between a frit and a substrate.

[0009] Exemplary embodiments of the present invention also provide a method of manufacturing an organic light emitting display device designed to improve a bonding force between a frit and a substrate.

[0010] Additional features of the invention will be set forth in the description which follows, and in part will be apparent from the description, or may be learned by practice of the invention.

[0011] An exemplary embodiment of the present invention discloses an organic light emitting display device comprising: a first substrate; a pixel array disposed on the first substrate; metal patterns disposed on the first substrate to surround the pixel array; a second substrate disposed on the first substrate; and a frit disposed between the first substrate and the second substrate, the frit covering the metal patterns.

[0012] An exemplary embodiment of the present invention also discloses a method for manufacturing an organic light

emitting display device, the method comprising: forming a pixel array on a first substrate; forming metal patterns on the first substrate to surround the pixel array; disposing a frit on the first substrate, the frit covering the metal patterns; disposing a second substrate opposite to the first substrate, overlapping with the pixel array, the metal patterns, and the frit; and bonding the frit to the first substrate and the second substrate to seal the pixel array.

[0013] It is to be understood that both the foregoing general description and the following detailed description are exemplary and explanatory and are intended to provide further explanation of the invention as claimed.

BRIEF DESCRIPTION OF THE DRAWINGS

[0014] The accompanying drawings, which are included to provide a further understanding of the invention and are incorporated in and constitute a part of this specification, illustrate exemplary embodiments of the invention, and together with the description serve to explain the principles of the invention.

[0015] FIG. 1 is a plan view illustrating an organic light emitting display device according to this embodiment of the present invention.

[0016] FIG. 2 is a sectional view taken along line 11-12 of FIG. 1.

[0017] FIG. 3 is a plan view illustrating a pixel array of FIG. 1.

[0018] FIG. 4 is a sectional view illustrating a pixel array of FIG. 1.

[0019] FIG. 5A is an enlarged plan view of portion A of FIG. 1.

[0020] FIG. 5B is an enlarged sectional view of portion A of FIG. 1.

[0021] FIG. 6A is an enlarged plan view of portion A of FIG. 1.

[0022] FIG. 6B is an enlarged sectional view of portion A of FIG. 1.

[0023] FIG. 7A is a plan view illustrating an organic light emitting display device according to one embodiment of the present invention.

[0024] FIG. 7B is a sectional view taken along line 111-112 of FIG. 7A.

[0025] FIG. 8A is a plan view illustrating an organic light emitting display device according to one embodiment of the present invention.

[0026] FIG. 8B is a sectional view taken along line 121-122 of FIG. 8A.

DETAILED DESCRIPTION OF ILLUSTRATED EMBODIMENTS

[0027] In the following detailed description, only certain exemplary embodiments of the present invention have been shown and described, simply by way of illustration. As those skilled in the art would realize, the described embodiments may be modified in various different ways, all without departing from the spirit or scope of the present invention. Accordingly, the drawings and description are to be regarded as illustrative in nature and not restrictive.

[0028] It will be understood that when an element or layer is referred to as being “on” or “connected to” another element or layer, it can be directly on or directly connected to the other element or layer, or intervening elements or layers may be present. In contrast, when an element is referred to as being

“directly on” or “directly connected to” another element or layer, there are no intervening elements or layers present. It will be understood that for the purposes of this disclosure, “at least one of X, Y, and Z” can be construed as X only, Y only, Z only, or any combination of two or more items X, Y, and Z (e.g., XYZ, XYY, YZ, ZZ).

[0029] FIG. 1 is a plan view illustrating an organic light emitting display device according to this embodiment of the present invention. FIG. 2 is a sectional view taken along line 11-12 of FIG. 1.

[0030] Referring to FIGS. 1 and 2, the organic light emitting display device includes a first substrate 100 having a pixel array 200 formed thereon, metal patterns 300 arranged on the first substrate 100 to surround the pixel array 200, a second substrate 400 disposed on the first substrate 100 to overlap with the pixel array 200 and the metal patterns 300, and a frit 500 disposed between the first substrate and the second substrate 400, the frit covering the metal patterns 300.

[0031] A driving circuit 600 and a pad portion 700 may be formed on the first substrate 100 outside the area surrounded by the frit 500. The driving circuit 600 may be configured to drive the pixel array 200. The pad portion 700 may be electrically connected to an external circuit to transmit an input signal to the driving circuit 600.

[0032] The first substrate 100 is formed in the shape of a thin film, and may be made of, for example, a glass, plastic, or metal.

[0033] The pixel array 200 may constitute a display unit configured to display image.

[0034] The second substrate 400 is disposed opposite to the first substrate 100, configured to seal the pixel array 200. In a front light emitting structure, the second substrate 400 may be made of a transparent material such as glass or plastic. In a rear light emitting structure, the second substrate 400 may be made of an opaque material.

[0035] The frit 500 is disposed between the first and second substrates 100 and 400 to surround the pixel array 200. The frit 500 is bonded to the first and second substrates 100 and 400 so that an internal space including the pixel array 200 is sealed.

[0036] The metal patterns 300 are disposed on the first substrate 100 to surround the pixel array 200. The metal patterns 300 are spaced apart from each other. The metal patterns 300 are interposed between the frit 500 and the first substrate 100.

[0037] Referring to FIG. 3, the pixel array 200 includes a plurality of scan lines 210 arranged in one direction, a plurality of data lines 220 arranged to intersect the scan lines 210, and a plurality of pixels 230 connected to the scan lines 210 and the data lines 220. The pixel 230 is a light-emitting device, which may include an organic light emitting diode.

[0038] The driving circuit 600 may include a scan driving circuit 600a connected to the plurality of scan lines 210, and a data driving circuit 600b connected to the plurality of data lines 220. The scan driving circuit 600a and the data driving circuit 600b may be implemented, for example, by an integrated circuit (IC).

[0039] Referring to FIG. 4, an organic light emitting diode 240 includes a first electrode 241, a second electrode 244, and an organic thin-film layer 243 interposed between the first and second electrodes 241 and 244. The organic thin-film layer 243 is formed on the first electrode 241 within a light emitting region, defined by an opening in a pixel defining layer 242. The organic thin-film layer may include a hole injection layer,

a hole transport layer, an organic emissive layer, an electron transport layer, and an electron injection layer.

[0040] The organic light emitting diode may further be connected to a thin film transistor configured to transmit a signal, and a capacitor configured to maintain the transmitted signal.

[0041] Referring to FIG. 4, a thin film transistor 250 includes a semiconductor layer 252 configured a source region, a drain region, and a channel regions, a gate electrode 254 insulated from the semiconductor layer 252 by a gate insulating layer 253, and a source or drain electrode 256 electrically connected to the semiconductor layer 252 in the source or drain region through a contact hole formed in an insulation layer 255 and the gate insulating layer 353. A planarization insulating layer 257 is disposed between the thin film transistor 250 and the organic light emitting diode 240. A buffer layer 251 may be disposed between the thin film transistor 250 and the base substrate 100.

[0042] A protective layer 260 may be formed on the first substrate 100 including the pixel array 200 to protect the organic light emitting diode 240. The protective layer 260 may be formed of an inorganic material to prevent the penetration of moisture or oxygen, and sustain against physical pressure. The protective layer 260 may also be either a single-layered or multi-layered structure.

[0043] FIGS. 5A and 5B are plan and sectional views illustrating an embodiment of the metal patterns 300, showing an enlarged portion A of FIG. 1.

[0044] Referring to FIGS. 5A and 5B, the metal patterns 300 may be arranged in a line and equally spaced apart from each other. For example, the distance d1 between the metal patterns 300 may be set to about 30 μm or more. According to an exemplary embodiment, the metal patterns 200 may be spaced apart from each other by about 30 μm to about 100 μm .

[0045] FIGS. 6A and 6B are plan and sectional views illustrating another exemplary embodiment of the metal patterns 300, showing an enlarged portion A of FIG. 1.

[0046] Referring to FIGS. 6A and 6B, the metal patterns 300 may be arranged in three lines and spaced apart from each other. For example, the distance d1 between the metal patterns 300 and the distance d2 between the lines may be set to about 30 μm or more. According to an exemplary embodiment, the distances d1 and d2 may each be in a range of about 30 μm to about 100 μm . The distances d1 and d2 need not equal each other.

[0047] Present invention is not limited to the above exemplary embodiments of the metal patterns 300. The plurality of metal pattern 300 may be arranged in any number of plural lines according to the size of the area sealed by the frit 500. The metal patterns 300 may be formed in a polygonal shape such as, but not limited to, a triangular, quadrangular or pentagonal shape. The metal patterns 300 may also be formed in a circular shape.

[0048] In an exemplary embodiment, the pixel array 200 may be sealed between the first substrate and the second substrate with the frit 500, by radiating laser or infrared light onto the frit 500 from a rear surface of the second substrate 400. As the frit 500 absorbs the radiated laser or infrared light, the frit 500 may melt from the heat generated from the laser or infrared light, and bond to the first and second substrates 100 and 400.

[0049] In an exemplary embodiment, the laser or infrared light radiated onto the frit 500 may be reflected and diffused on the metal patterns 300. The reflection and diffusion of the

radiated laser or infrared light may uniformly increase the temperature of the entire section of the frit **500**, so that the entire section of the frit **500** may uniformly bond to the first substrate **100** and the second substrates **400**.

[0050] In general, the energy of laser or infrared light has a Gaussian distribution. Therefore, a direct radiation of the laser or infrared light to the frit **500** will generate inconsistent heat distribution on the frit, and result in poor bonding of the two substrates **100** and **400**. This poor bonding of the substrates from inconsistent heat distribution may be overcome by the metal patterns **300** of the exemplary embodiment, which reflect and diffuse the laser or infrared light to melt the frit and bond the substrates uniformly.

[0051] Similar effect may be obtained by a linear metal strip design instead of the metal patterns **300** of current exemplary embodiment of the invention. However, the linear metal strip design may be weak against electrostatic discharge. The substrate of the organic light emitting display device is made of glass or the like; hence the electrostatic discharge may be frequently generated during the fabrication or application of the organic light emitting display device. Since the metal patterns **300** are peripherally disposed surrounding the two substrates **100** and **400**, the metal patterns **300** may be directly influenced by the electrostatic discharge, which may exfoliate the metal patterns or destroy the frit **500** sealing. The issue of the electrostatic discharge may be overcome by designing metal patterns **300** in the form of independent islands, preventing the potential electrostatic discharge from conducting along the metal patterns **300**, thus minimizing the Joule's heat and the electrostatic discharge towards the pixel array.

[0052] In one exemplary embodiment, the distance **d1** between the metal patterns **300** and the distance **d2** between the lines may be set to 30 μm or more, for example about 30 μm to about 100 μm . In a case where the distances **d1** and **d2** are set to less than 30 μm , it may be difficult to prevent damage caused by the electrostatic discharge. In a case where the distances **d1** and **d2** are set to more than 100 μm , it may be difficult to obtain the effect caused by the reflection and diffusion of the laser or infrared light.

[0053] FIGS. **7A** and **7B** are plan and sectional views illustrating an organic light emitting display device according to an exemplary embodiment of the present invention.

[0054] Referring to FIGS. **7A** and **7B**, an insulating layer **280** is interposed between a first substrate **100** including metal patterns **300** and a frit **500**. Holes **270** are formed in the insulating layer **280** to surround each metal pattern **300**.

[0055] The frit **500** may flow into the holes **270** during the process of melting the frit **500** by laser or infrared light, and directly bond to the first substrate **100**. The holes **270** may increase the bonding surface area of the frit **500** to the insulating layer **280** and the first substrate **100**.

[0056] Referring to FIGS. **4**, **7A**, and **7B**, when the gate electrode **254** or the source or drain electrode **256** is formed in the process of fabricating the thin film transistor **250**, the metal patterns **300** may be formed of the same material, e.g., at least one of aluminum (Al), titanium (Ti), and molybdenum (Mo). The insulating layer **280** may be formed into a single- or multi-layered structure in the process of forming the gate insulating layer **253**, the insulation layer **255**, and the protective layer **260**.

[0057] In an exemplary embodiment, a buffer layer **251** may be formed on the first substrate **100**, and the metal patterns **300** may then be formed on the buffer layer **251**, electrically insulating the metal patterns **300** from one

another. The buffer layer **251** may be formed with a silicon oxide layer (SiO_2), silicon nitride layer (SiN_x), or laminated structure thereof.

[0058] FIGS. **8A** and **8B** are plan and sectional views illustrating an organic light emitting display device according to an exemplary embodiment of the present invention.

[0059] Referring to FIGS. **8A** and **8B**, an insulating layer **280** is interposed between a first substrate **100** including metal patterns **300** and a frit **500**. A trench **270a** is formed in the insulating layer **280** to surround each metal pattern **300**.

[0060] The trench **270a** has a structure in which the holes **270** shown in FIGS. **7A** and **7B** are connected to one another, further increasing the bonding surface area of the frit **500** to the insulating layer **280** and the first substrate **100** compared to the structure of FIGS. **7A** and **7B**.

[0061] In one exemplary embodiment, the buffer layer **251** may be formed on the first substrate **100**, electrically insulating the metal patterns **300**. The buffer layer **251** may be formed with a silicon oxide layer (SiO_2), silicon nitride layer (SiN_x), or laminated structure thereof.

[0062] Although the exemplary embodiments discussed above disclose metal patterns **300** disposed on the first substrate **100**, the metal patterns **300** of FIGS. **5-8** may alternatively be disposed on the second substrate **400**. Furthermore, in other exemplary embodiments, metal patterns **300** may be disposed on both the first substrate **100** and the second substrate **400**.

[0063] It will be apparent to those skilled in the art that various modifications and variations can be made in the present invention without departing from the spirit or scope of the invention. Thus, it is intended that the present invention cover the modifications and variations of this invention provided they come within the scope of the appended claims and their equivalents.

What is claimed is:

1. An organic light emitting display device, comprising:
 - a first substrate;
 - a pixel array disposed on the first substrate;
 - metal patterns disposed on the first substrate to surround the pixel array;
 - a second substrate disposed on the first substrate; and
 - a frit disposed between the first substrate and the second substrate, the frit covering the metal patterns.
2. The organic light emitting display device of claim 1, wherein the metal patterns are arranged in plural lines.
3. The organic light emitting display device of claim 2, wherein the distance between the metal patterns and the distance between the lines are each in a range of about 30 to about 100 μm .
4. The organic light emitting display device of claim 1, wherein the metal patterns have a polygonal shape.
5. The organic light emitting display device of claim 1, further comprising an insulating layer disposed between the frit and the first substrate.
6. The organic light emitting display device of claim 5, wherein the insulating layer comprises a multi-layered structure.
7. The organic light emitting display device of claim 5, further comprising holes in the insulating layer surrounding each metal pattern.
8. The organic light emitting display device of claim 5, further comprising a trench in the insulating layer surrounding each metal pattern.

9. The organic light emitting display device of claim 1, wherein the metal patterns comprise at least one of aluminum (Al), titanium (Ti), and molybdenum (Mo).

10. The organic light emitting display device of claim 1, further comprising a buffer layer disposed between the metal pattern and the first substrate.

11. A method for manufacturing an organic light emitting display device, the method comprising:

- forming a pixel array on a first substrate;
- forming metal patterns on the first substrate to surround the pixel array;
- disposing a frit on a second substrate, the frit corresponding to the metal patterns;
- disposing the second substrate opposite to the first substrate; and
- bonding the frit to the first substrate and the second substrate to seal the pixel array.

12. The method of claim 11, wherein the bonding of the frit comprises:

- radiating laser or infrared light onto the frit from a rear surface of the second substrate; and
- melting the frit by reflecting and diffusing the radiated laser or infrared light on the metal patterns.

13. The method of claim 11, further comprising:
forming, before disposing the frit on the second substrate, an insulating layer on the metal patterns; and

forming holes in the insulating layer surrounding each metal pattern.

14. The method of claim 13, wherein the bonding of the frit further comprises:

- radiating laser or infrared light onto the frit from a rear surface of the second substrate; and
- melting the frit by reflecting and diffusing the radiated laser or infrared light on the metal patterns.

15. A method of claim 14, further comprising forming a buffer layer on the first substrate, the pixel array being disposed on the buffer layer.

16. The method of claim 11, further comprising:
forming, before disposing the frit on the second substrate, an insulating layer on the metal patterns; and
forming a trench in the insulating layer surrounding each metal pattern.

17. The method of claim 16, wherein the bonding of the frit further comprises:

- radiating laser or infrared light onto the frit from a rear surface of the second substrate; and
- melting the frit by reflecting and diffusing the radiated laser or infrared light on the metal patterns.

18. The method of claim 17, further comprising forming a buffer layer on the first substrate, the pixel array being disposed on the buffer layer.

* * * * *

专利名称(译)	有机发光显示装置		
公开(公告)号	US20150021573A1	公开(公告)日	2015-01-22
申请号	US14/325079	申请日	2014-07-07
[标]申请(专利权)人(译)	三星显示有限公司		
申请(专利权)人(译)	三星DISPLAY CO. , LTD.		
当前申请(专利权)人(译)	三星DISPLAY CO. , LTD.		
[标]发明人	KWAK WON KYU		
发明人	KWAK, WON-KYU		
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CPC分类号	H01L27/3276 H01L27/3253 H01L51/5246 H01L27/3244		
优先权	1020130085854 2013-07-22 KR		
其他公开文献	US9312509		
外部链接	Espacenet USPTO		

摘要(译)

有机发光显示装置包括第一基板，像素阵列，金属图案，第二基板和玻璃料。像素阵列设置在第一基板上。金属图案布置在第一基板上以围绕像素阵列。第二基板设置在第一基板上。玻璃料设置在第一基板和第二基板之间，玻璃料覆盖金属图案。

